

# Material Surface Science Laboratory @ LNF: research activity and laboratory resources

ET Italia: 1° Workshop on Coatings

30<sup>th</sup> May 2024

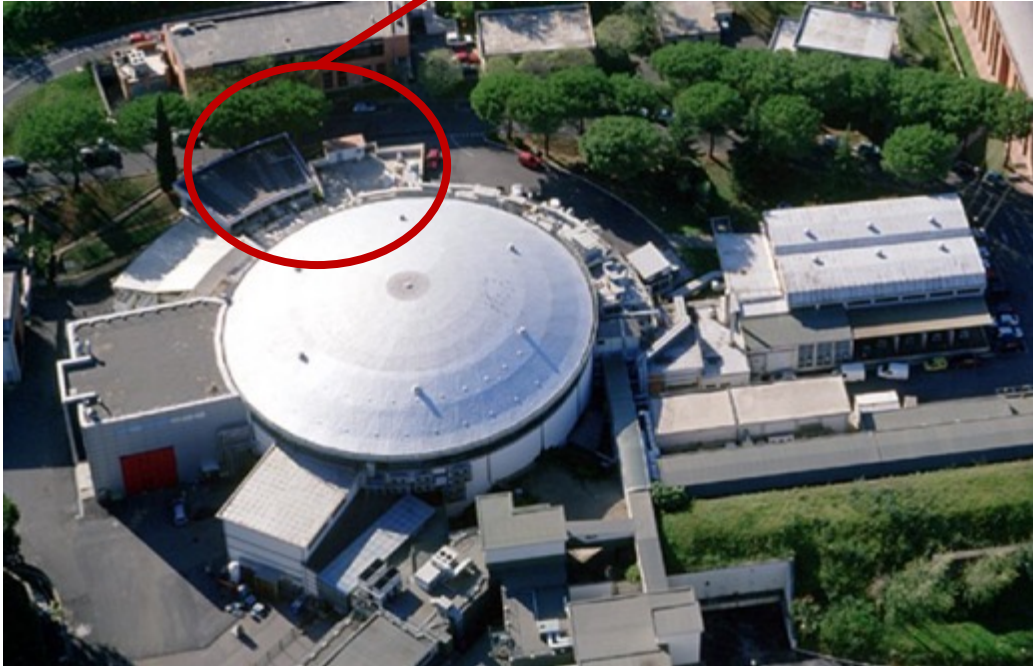
Marco Angelucci, Luisa Spallino and Roberto Cimino

LNF-INFN

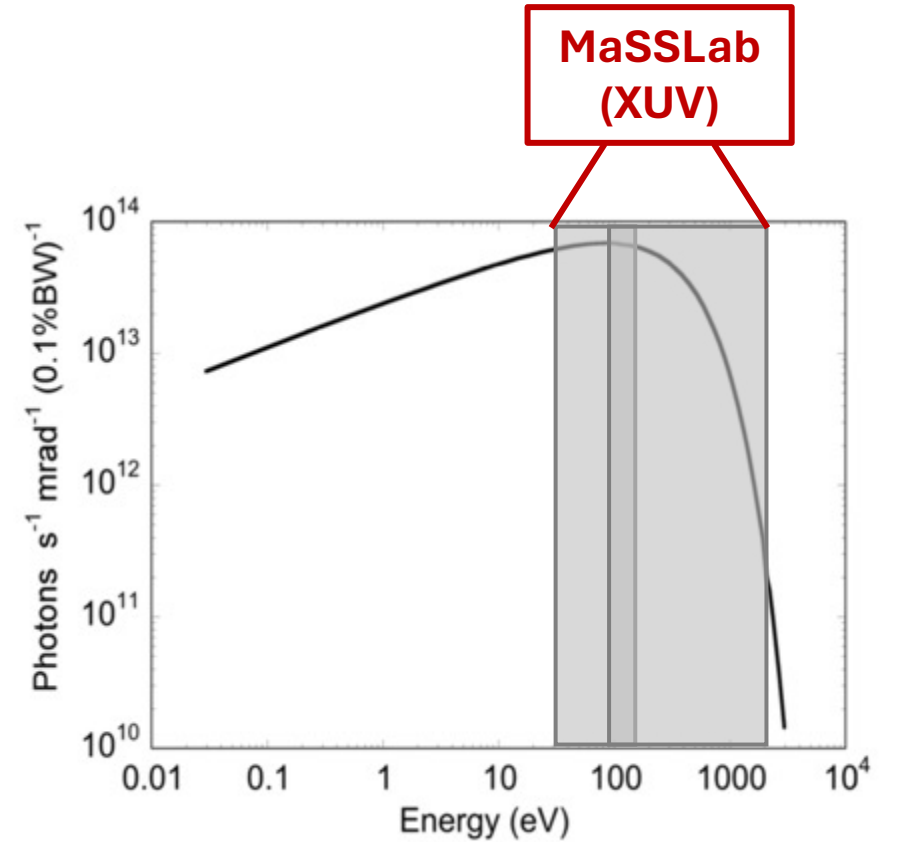


# Where we are

DAΦNE-L synchrotron light laboratories



DAΦNE collider in Frascati



# Research Activities

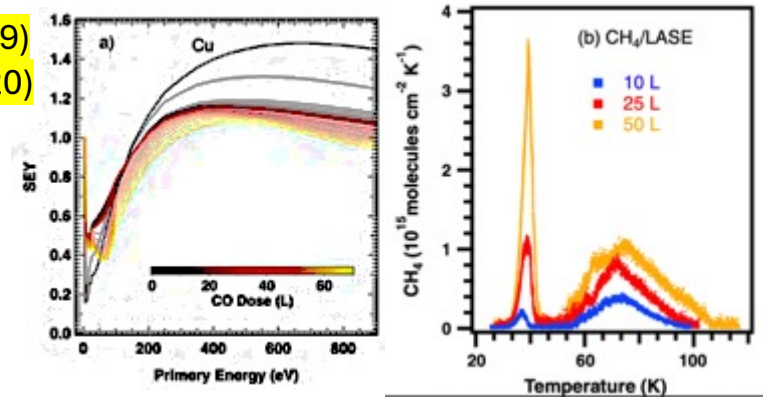
Secondary Electron Emission from UHV vacuum chamber surface

➔ Electron Cloud Instabilities

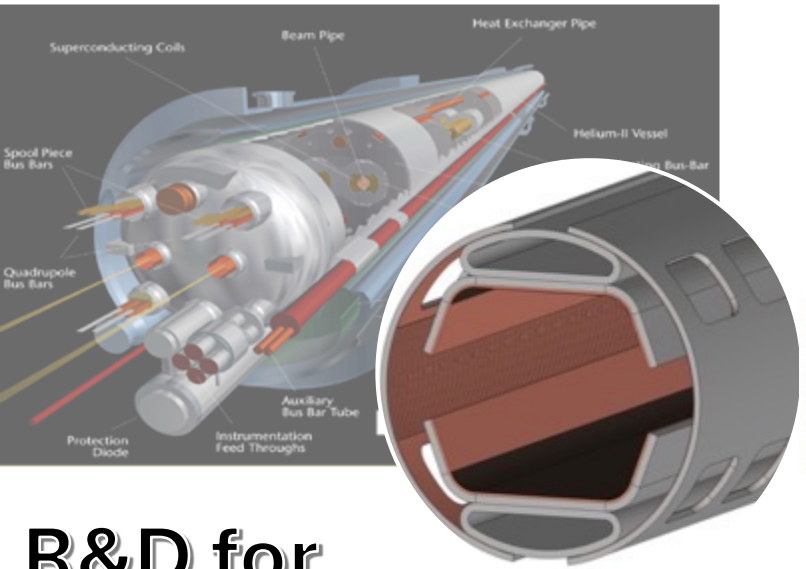
Condensed gases on porous surfaces

➔ Vacuum Instabilities

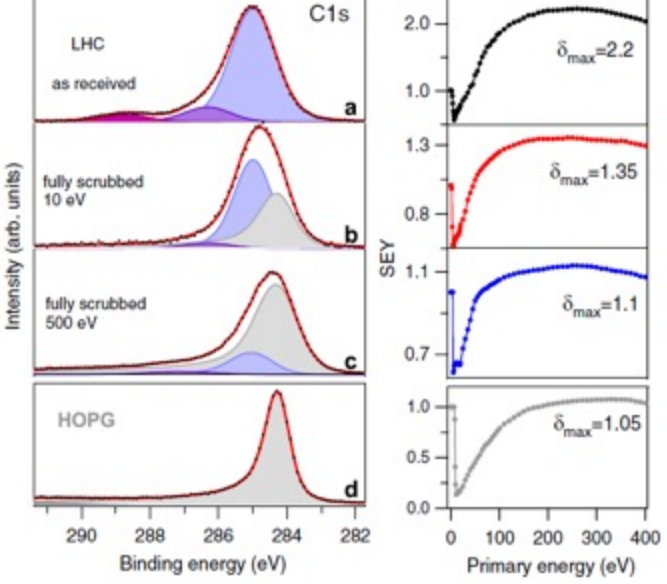
L. Spallino et al. Appl. Phys. Lett. (2019)  
 L. Spallino, J. Vac. Sci. Technol. B (2020)  
 L. Spallino et al., Phys. Rev. Accel. Beams (2020)



Studies at Cryogenic temperature (10 K)



R. Cimino et al., Phys. Rev. Lett. (2012)

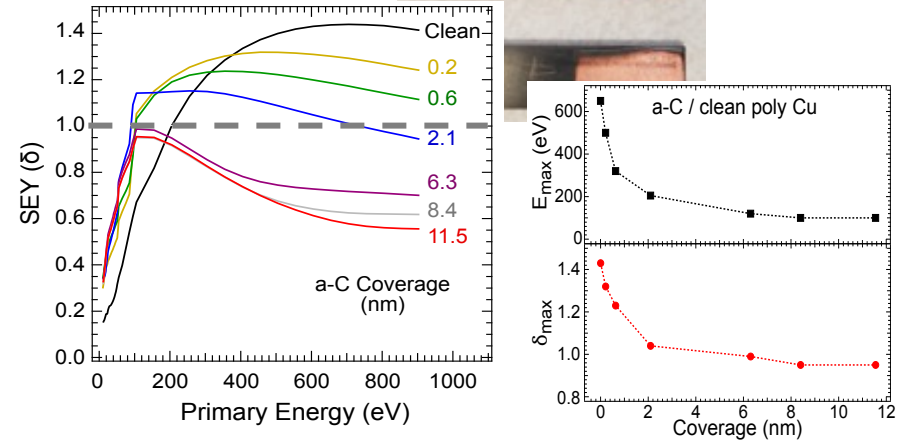


Surface conditioning with electrons

M. Angelucci LNF-INFN



M. Angelucci et al., Phys. Rev. Res. (Rapid Comm.) (2021)



Studied for electron cloud and multipacting mitigation<sup>3</sup>

R&D for accelerators



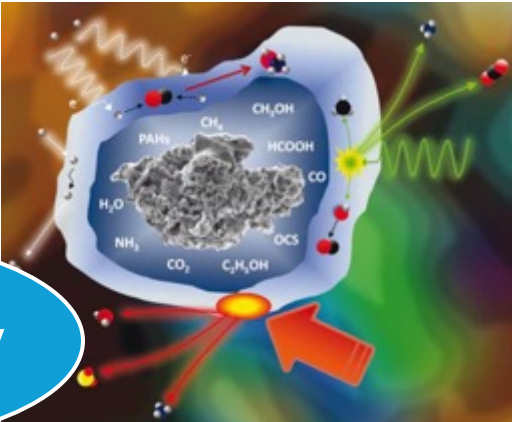
30-31 Maggio 2024

# Multidisciplinary Activities



Space and Satellites

Multipacting

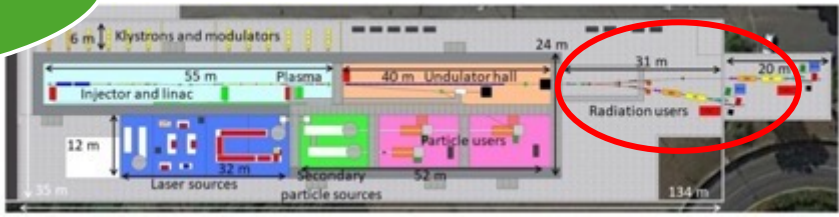
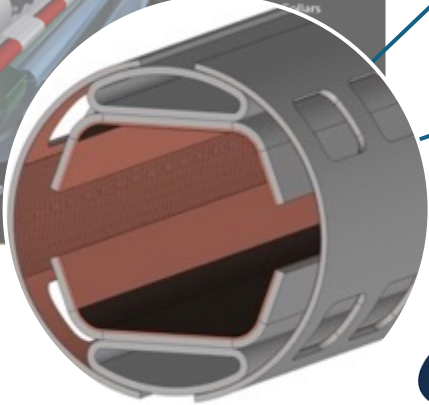
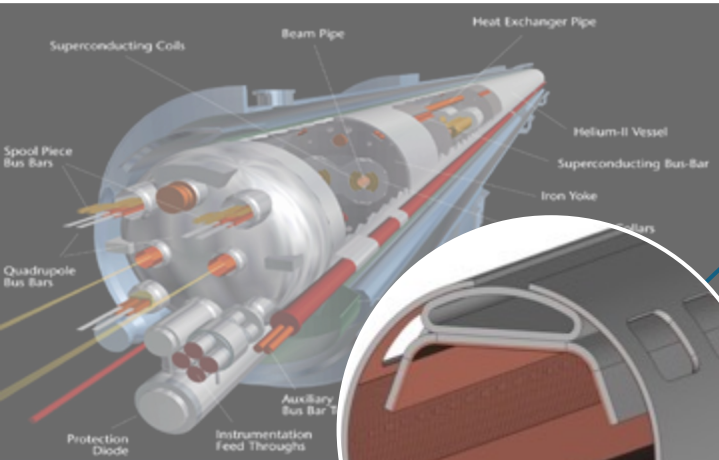


Thermal and non thermal desorption of condensed gases on interstellar medium.

Astrochemistry

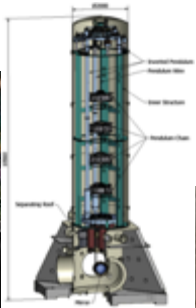
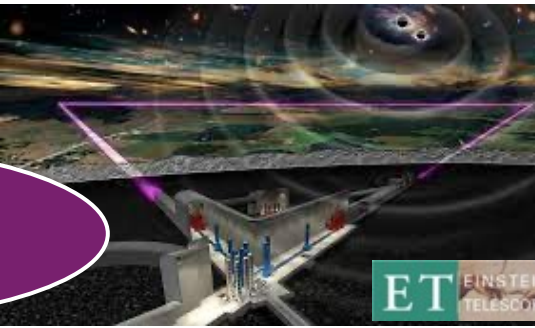
Eupraxia@Sparc\_Lab

Vacuum system and beamlines



R&D for Accelerators

Einstein Telescope

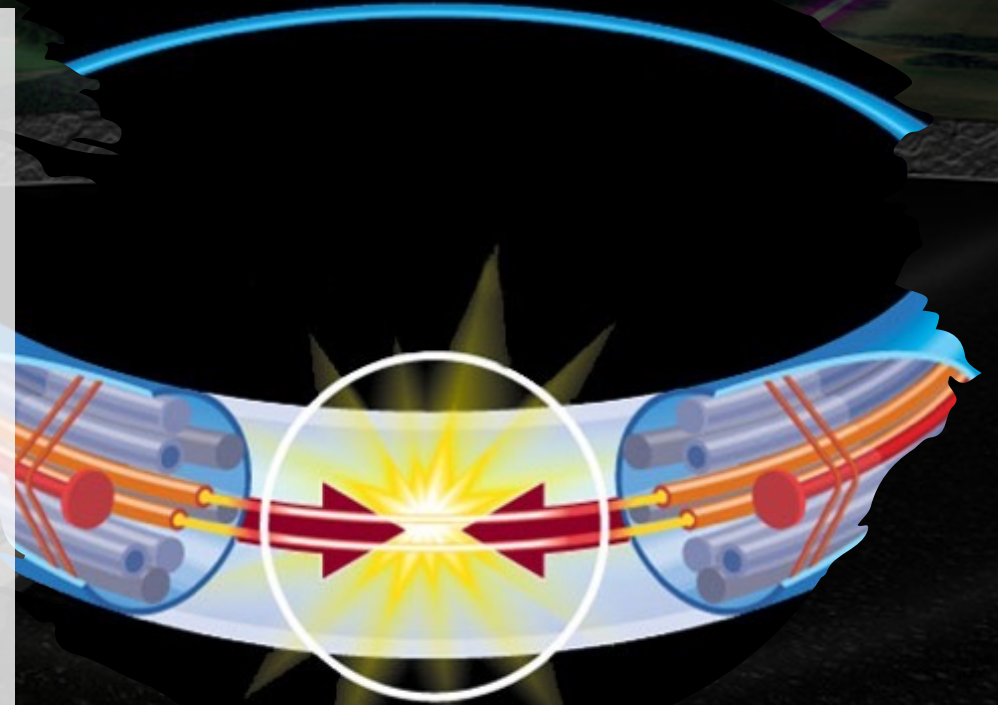


Cyogenic vacuum of towers and beampipes vacuum

# Synergies between dynamic vacuum issues in accelerators and GW instrumentations

## Common standard vacuum issues

- Installations and running of huge vacuum and cryogenic systems
- Joints, flanges, valves etc. R&D
- Pumps and diagnostic (gauges, mass spectrometers and related R&D)
- Vacuum calculations
- R&D on new materials, material's coatings and/or surface treatments to reduce surface degassing to limit vacuum pumps and contain vacuum costs!



## Unconventional GWO issues

### Cryosorption on cold optics (frost):

- KAGRA GWO suffers from gas cryosorbed on the mirror surface inducing detrimental effects on the optics.
- Warming up should be avoided (time consuming)

### Electrostatic charge of mirrors

- Both VIRGO and LIGO optics undergo to inhomogeneous electrostatic charging of variable (or unknown) sign that may induce unwanted noise.
- procedures are undertaken for neutralization with positive/neg ions (**Not applicable at LT**)

See presentation of tomorrow!

Electrons

# ET ITALIA @ LNF (Gr II)

## WP1: Frost mitigation and Electrostatic Charging *(MaSSLab)*

The final goal of this WP is to validate the use of low energy electrons as a mitigation method for frost formation and as a neutralization method for mirrors' electrostatic charging.

## WP2: Material Properties

*(Vacuum Group – Latino @ LNF in collaboration with MaSSLab & EGO/Virgo)*

The aim of this WP is the characterization of the materials involved in the tower vacuum system containing the mirrors. The investigation of the outgassing properties will define the level and quality of vacuum surrounding the mirror surfaces.

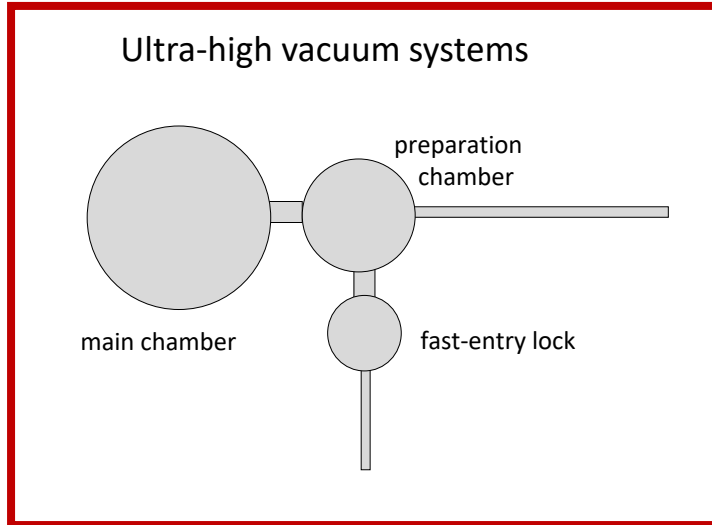
## WP3: Passive mitigation method for electrostatic charging

*(MaSSLab in collaboration with EGO/Virgo & IFAE and Vacuum Group @ LNF )*

The aim of this WP is to carry out a R&D activity to develop a passive mitigation strategy for the electrostatic charging generated by low energy electrons coming from ion pumps, propagating along the beampipes and finally impinging on the test masses .

ET-ISB Division IV  
Vacuum and  
Cryogenics

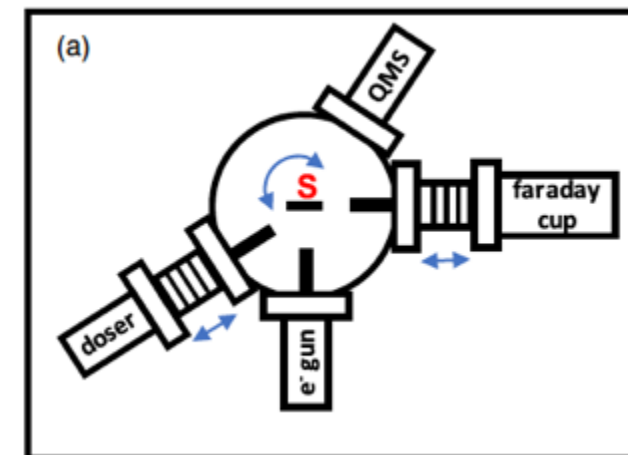
# Experimental stations at MaSSLab



2 UHV systems ( $P \sim 1 \times 10^{-10}$  mbar) equipped with a cryogenic manipulator ( $T_{\text{sample}} \sim 10 - 300$  K)

a UHV system ( $P \sim 1 \times 10^{-10}$  mbar) for measurements at RT

## Main chamber

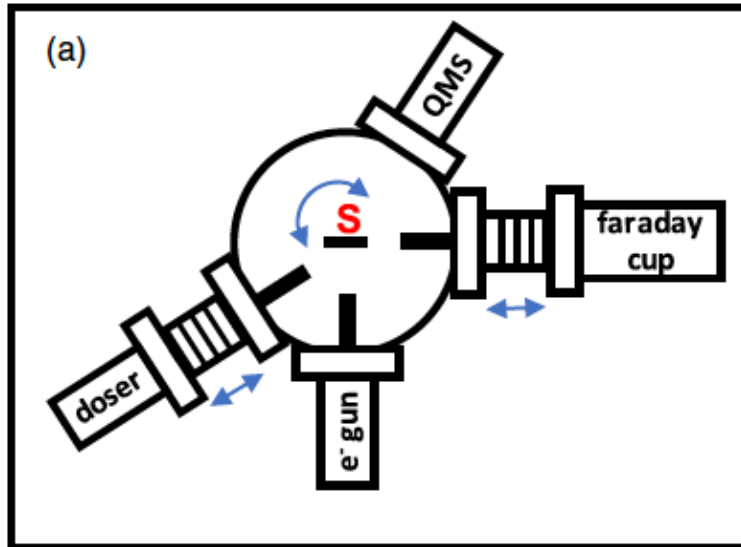
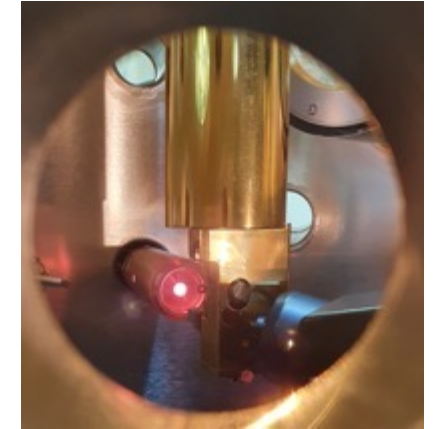


Common elements of the main chambers:

- Set-up for SEY measurements, TPD and electron irradiation
- Gas line and Quadrupole Mass Spectrometer (QMS)



# Experimental stations at MaSSLab



## LE Chamber:

+ Atomic Hydrogen Source  
(under test)

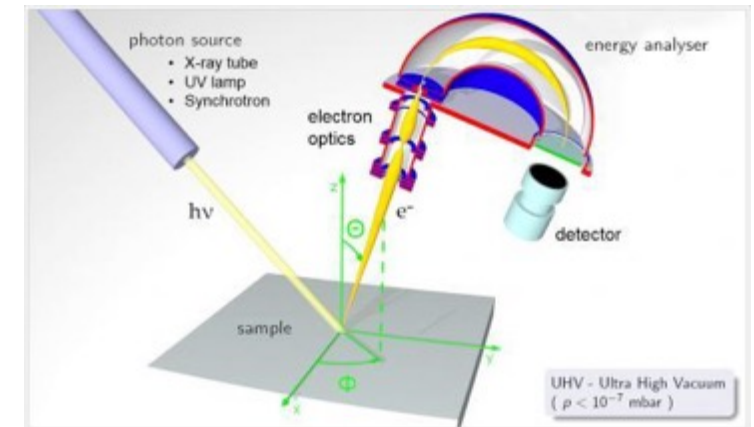
## RT Chamber:

+ XPS set-up (Al and Mg  
nonmonocromatic sources)

## HE Chamber:

➤ + XPS set-up (Al and Ag  
monocromatic and Al and Mg  
nonmonocromatic sources)

➤ + Electron flood gun



# Experimental stations at MaSSLab

**LE and RT Preparation Chamber:**  
Sputtering and thermal heating

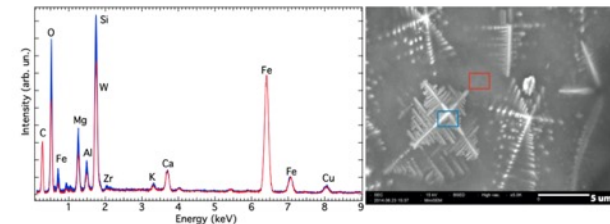
- HE Preparation Chamber:**
- Sputtering and thermal heating
  - Electron beam evaporator



# Experimental stations at MaSSLab

## More in lab

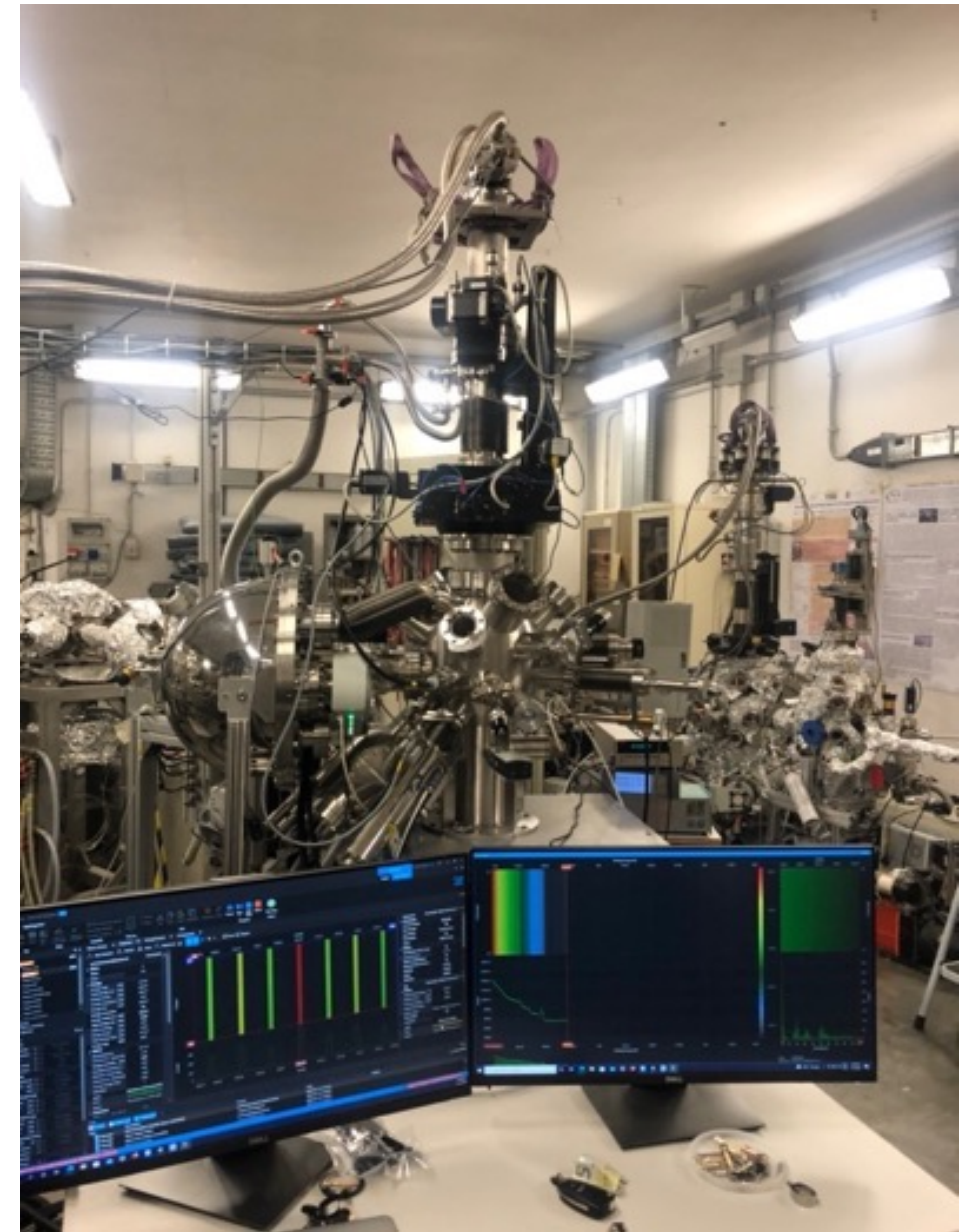
- Raman microscope (fundamental at 532 nm) that can be coupled to the UHV chamber by optical fiber (coupling to be implemented)
- Furnace for chemical vapour growth of materials on substrates
- SEM + EDS for surface characterization



# Experimental stations at MaSSLab

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- Electron guns (Secondary Electron Yield, conditioning, charging)
- Kelvin Probe
- XPS/UPS
- TDS (10-300 K or 300-1000 K )
- QMS
- CVD
- Raman
- LEED/Auger
- SEM
- EDS



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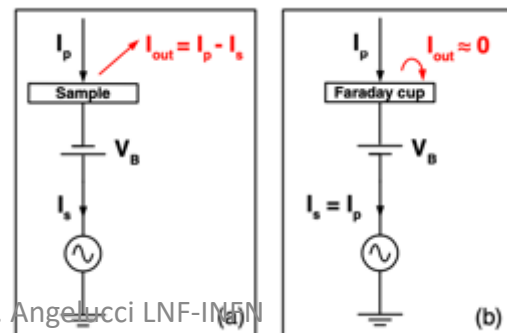
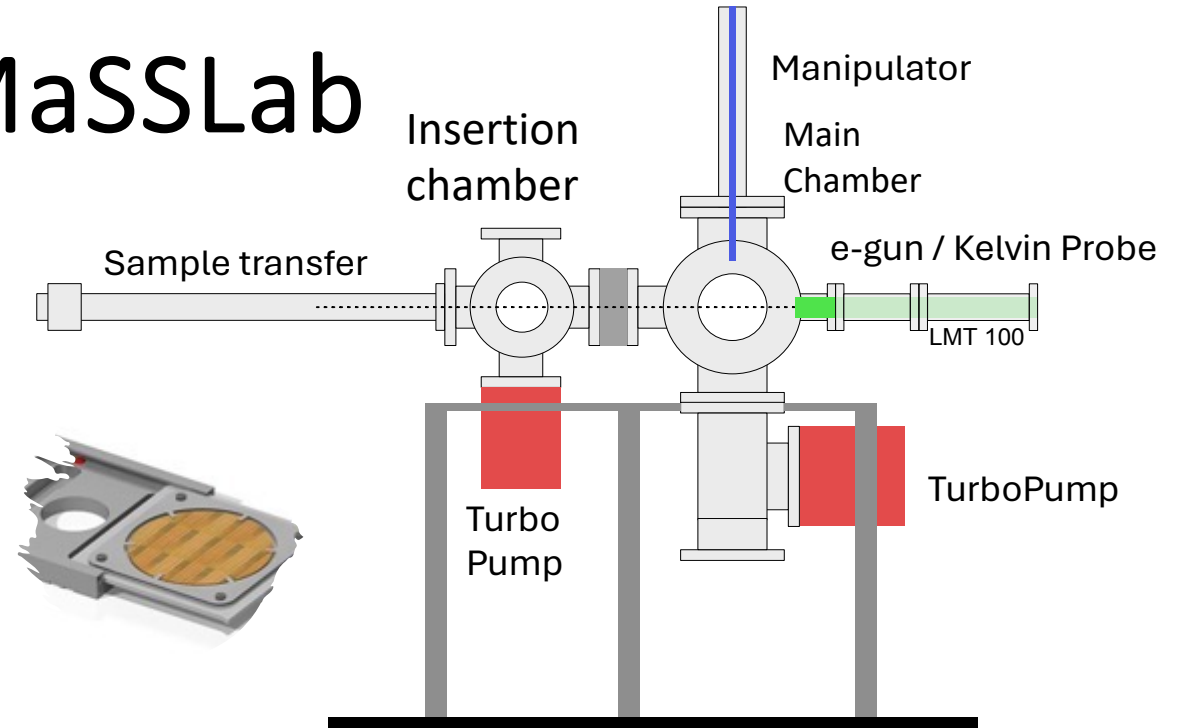
ET-ISB Division IV  
Vacuum and  
Cryogenics

# Experimental stations at MaSSLab

## Implementation during 2024

The system will be composed by:

- a UHV chamber equipped with:
  - Electron gun (from Kimball)
  - Kevin Probe from (KP technologies)
  - 4-axis manipulator remotely controlled, with a **specific sample holder for 1" sample**
- An UHV insertion chamber with:
  - **A magnetic transfer equipped with a specific sample grabber**
- Picoammeters for primary and sample current measurements
- **Sample holder.**



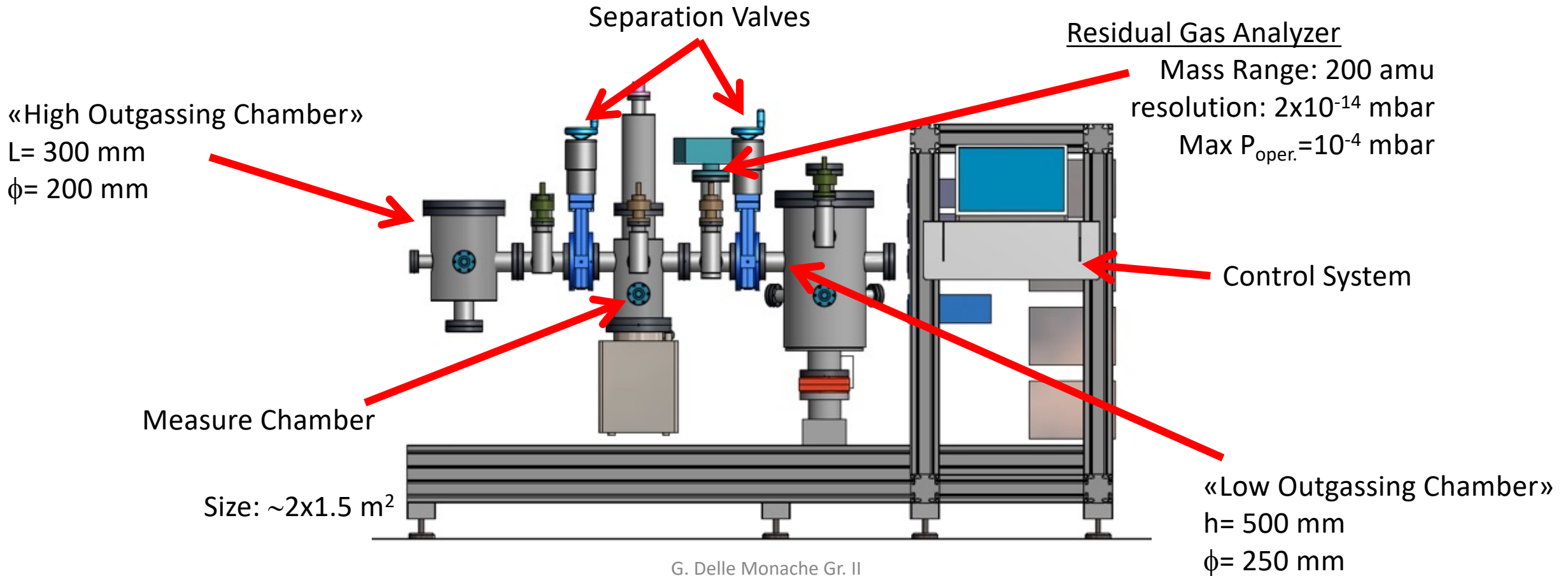
M. Angelucci LNF-INFN (a)



# WP2: Material Properties

(Vacuum Group – Latino @ LNF in collaboration with MaSSLab & EGO/Virgo)

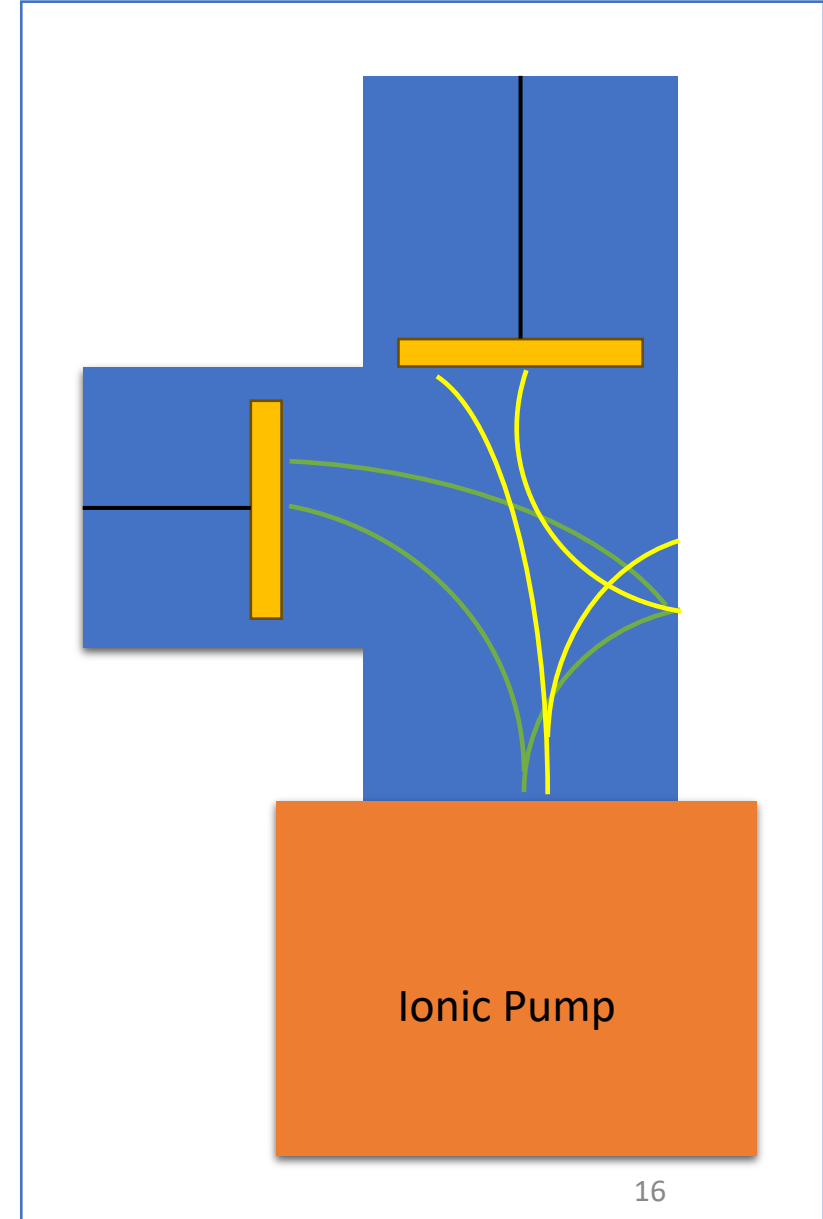
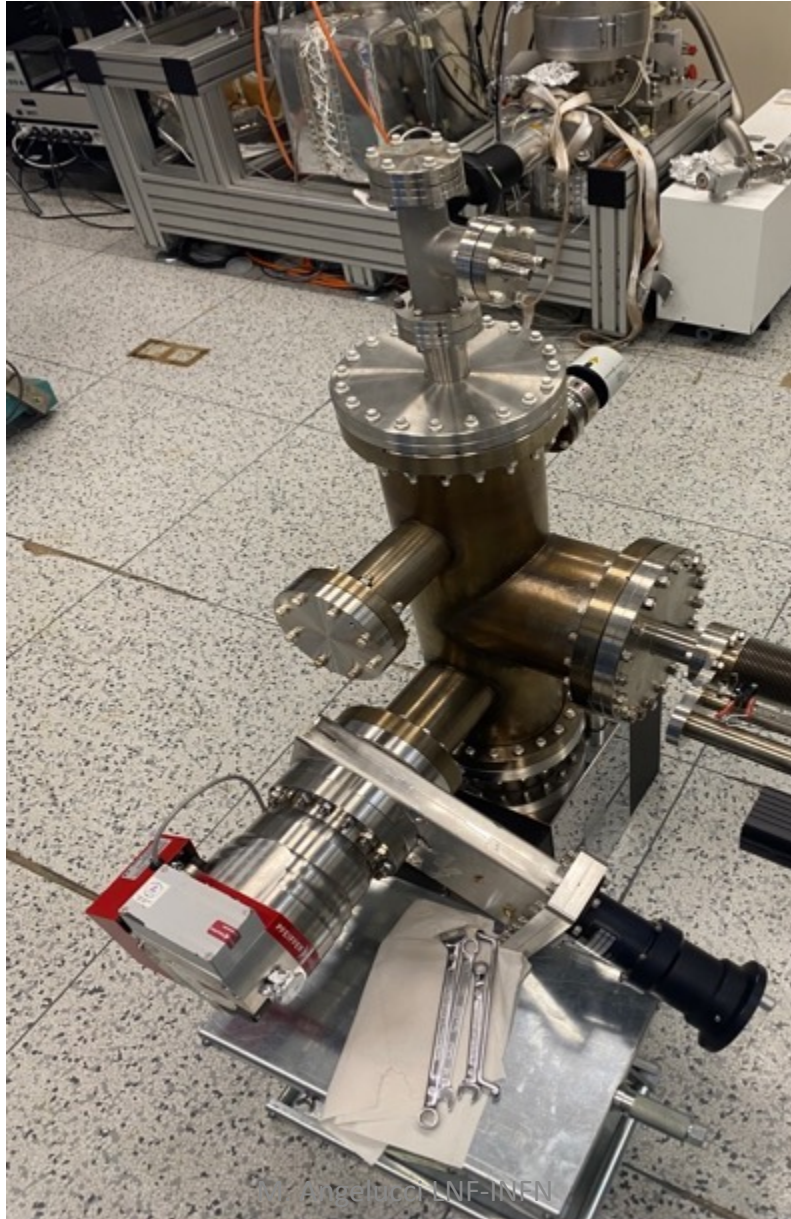
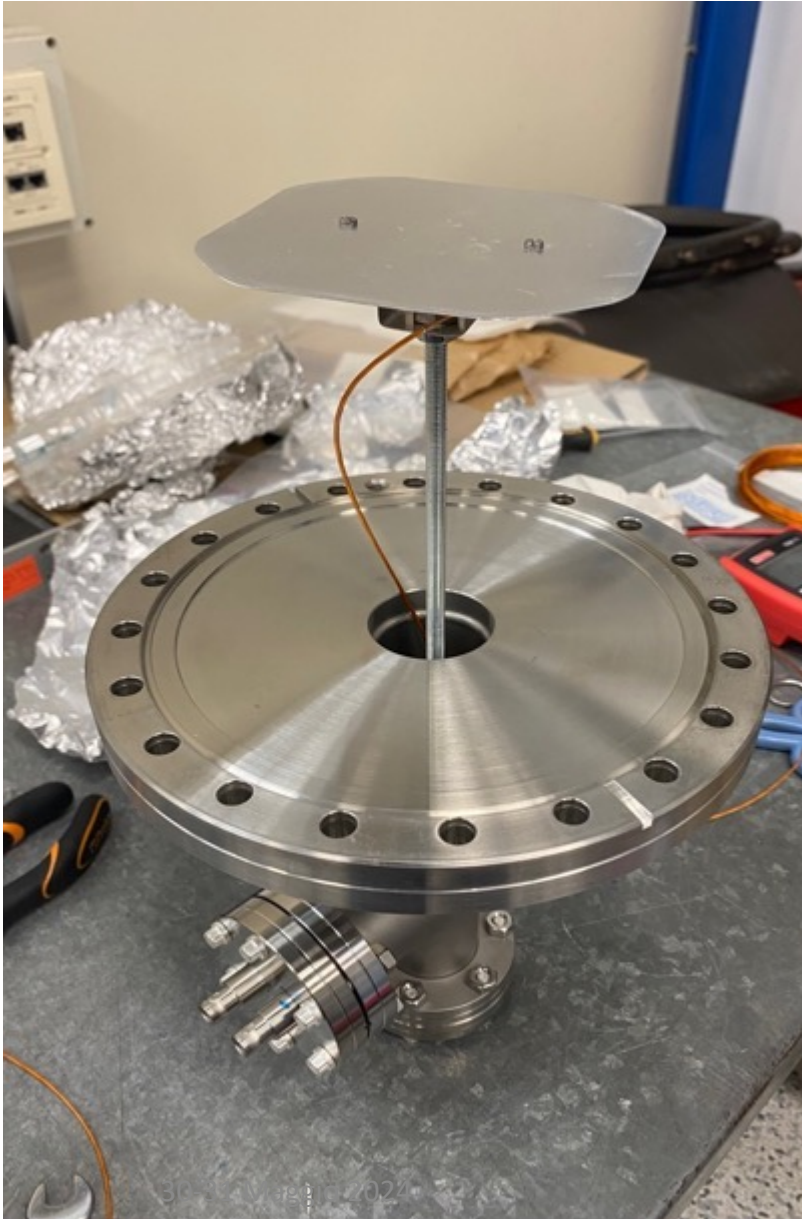
## LATINO «OUTGASSING RATE SYSTEM» AT LNF-INFN



LATINO (Laboratory in Advanced Technologies for INNOvation) is a cofunded project (INFN-Regione Lazio) - Call "Open Research Infrastructure"

# WP3: Passive mitigation method for electrostatic charging

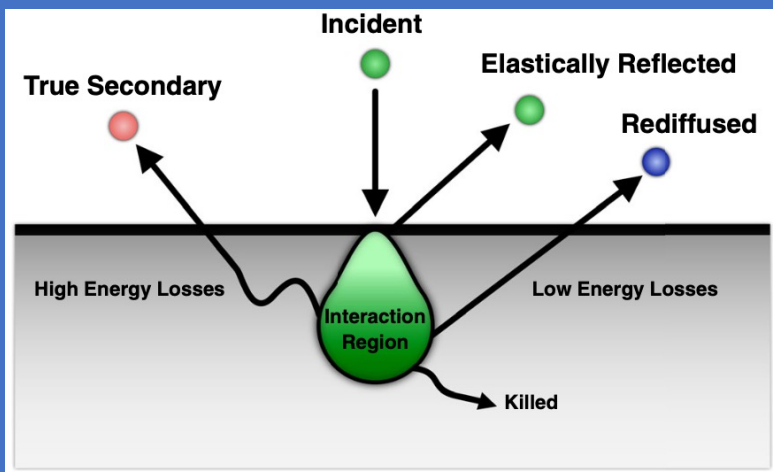
(MaSSLab in collaboration with EGO/Virgo & IFAE and Vacuum Group @ LNF)





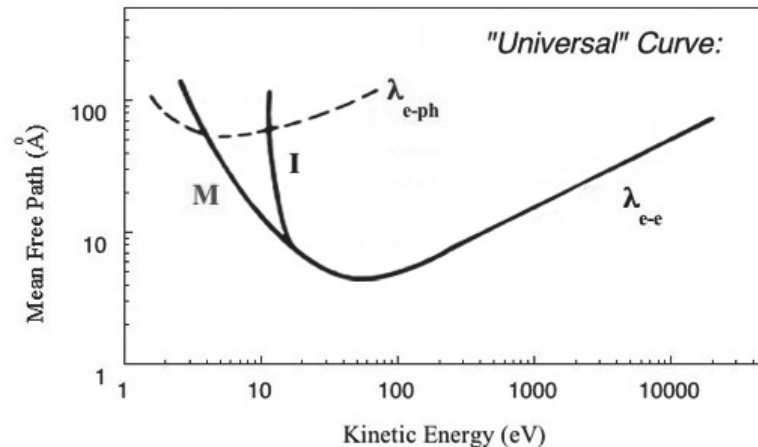
# Secondary Electron Yield

## Secondary Electron emission



### Three-step process:

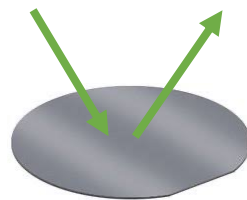
- Production of SE at a depth  $z$
- Transport of the SE toward the surface
- Emission of SE across the surface barrier



Electron mean free path up to  $\sim 10$  nm

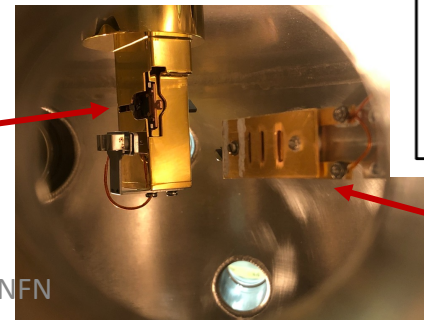
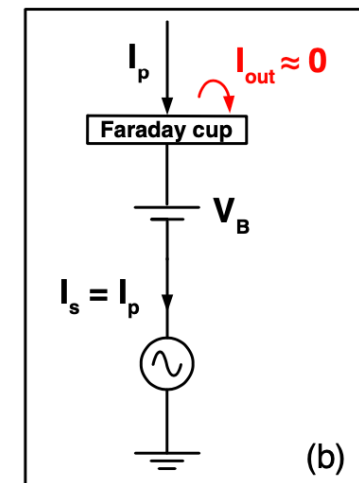
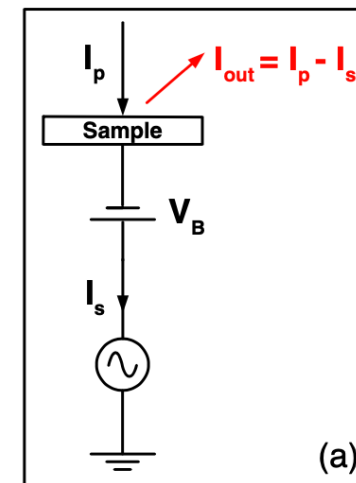
**SEY is an intrinsic surface property of materials**

Incident electrons current ( $I_p$ )  
Emitted electrons current ( $I_{out}$ )



Sample

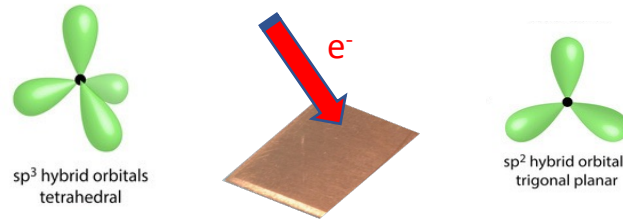
Farady cup



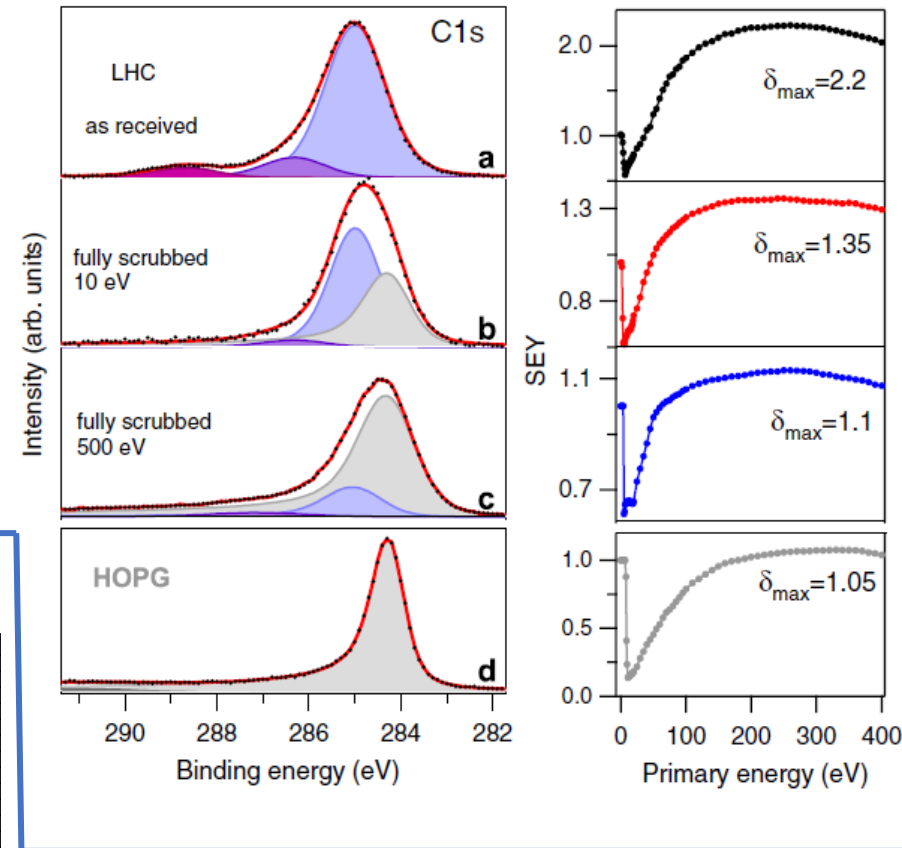
# Secondary Electron Yield

$sp^3 \rightarrow sp^2$  carbon surface contamination conversion

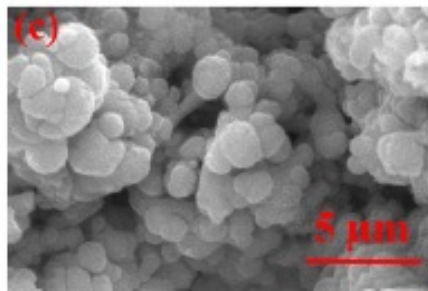
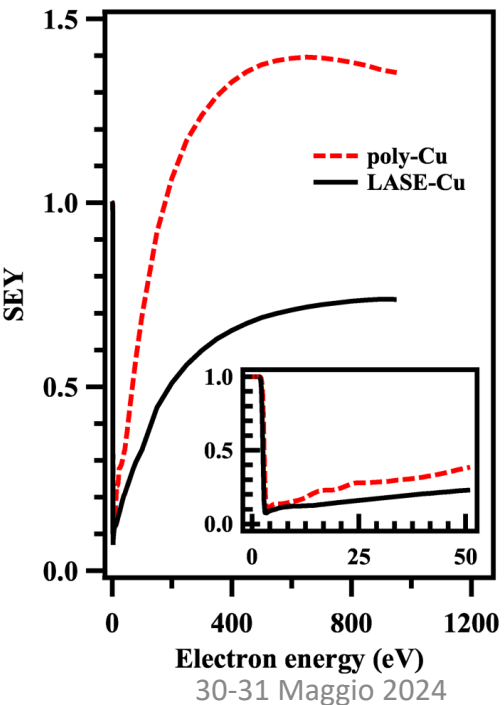
- SEY depends on the surface chemical state



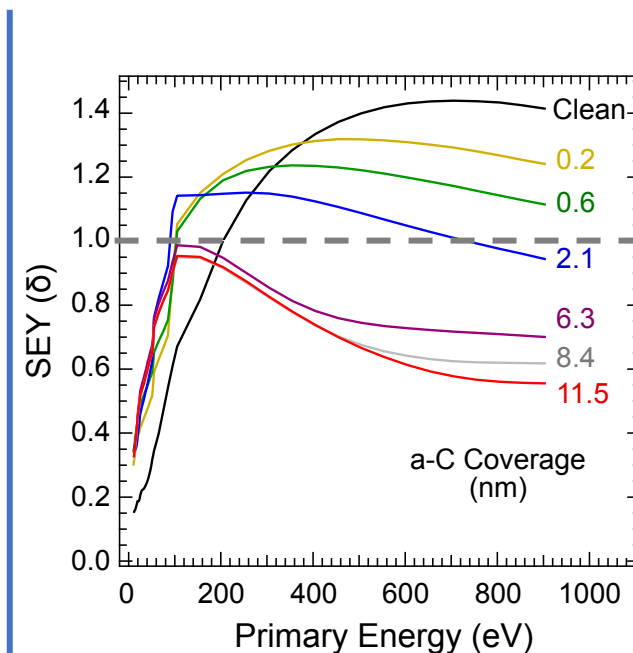
As received LHC-Cu sample



L. Spallino, J. Vac. Sci. Technol. B (2020)



- SEY depends on the surface morphology



M. Angelucci LNF-INFN

- SEY depends on the coverage thickness, even at sub-monolayer coverage

M. Angelucci et al., Phys. Rev. Res. (Rapid Comm.) (2021)